

FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office				Attorney Docket No. 297/104/2		Serial No. 0997162	
List of Documents Cited by Applicant						RECEIVED JUL 16 2003 GROUP 1700	
				Applicant(s): Cuomo et al.			
				Filing Date: November 29, 2001		Group: 1753	
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EXAMINER

Robert M. Donald

DATE CONSIDERED

7/22/03

*Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.